



GAU 2812

**PATENT**  
0756-1936

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of )  
Shunpei YAMAZAKI et al. )  
Serial No. 09/255,777 )  
Filed: February 23, 1999 )  
For: SEMICONDUCTOR DEVICE )  
AND METHOD FOR )  
FORMING THE SAME )

Group Art Unit: 2812

Examiner: R. Booth

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on:

**June 7, 2000.**

*Melissa McKibben*  
**Melissa McKibben**

Transmittal

Assistant Commissioner for Patents  
Washington, D.C. 20231

**June 7, 2000**

Sir:

Transmitted herewith is **an Amendment** in the above-identified application.

The fee has been calculated as shown below:


	Claims Remaining After Amendment		Highest Number Previously Paid For	Present Extra	Small/Large Entity Rate	Fee
Total	59	Minus	33	26	X \$18.00	\$468.00
Indep.	12	Minus	6	6	X \$78.00	\$468.00
First Presentation of Multiple Dependent Claim					\$260.00	\$0.00
TOTAL						\$936.00

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- [ X ] A check in the amount of **\$936.00** is enclosed for the fees associated with additional claims.
- [ X ] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380.
- [ X ] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. **A duplicate copy of this sheet is attached.**

Respectfully submitted,

NIXON PEABODY LLP



Eric J. Robinson

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*EJR:mmc*

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#61B  
6-15-00  
R. Hader

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*Melissa McKibben*  
Melissa McKibben

**AMENDMENT**

Assistant Commissioner for Patents  
Washington, D. C. 20231

June 7, 2000

Sir:

In response to the Office Action mailed March 7, 2000, please amend the above-identified application as follows:

In the claims:

Please cancel claims 20 and 25.

Please amend the claims as follows:

1. (Amended) A method for fabricating a semiconductor device, comprising the steps of:
- forming a semiconductor film comprising amorphous silicon on an insulating surface;
- forming an insulating film on said semiconductor film;
- introducing boron into at least a portion of said semiconductor film through

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02 FC:102

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